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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of:

KHALIL NAJAFI, ET AL.

Group Art Unit: 2215

Examiner: Alonzo Chambliss

Serial No.: 10/688,417

Filed: October 17, 2003

For: MANUFACTURING METHODS AND VACUUM OR
HERMETICALLY PACKAGED MICROMACHINED OR
MEMS DEVICES FORMED THEREBY HAVING
SUBSTANTIALLY VERTICAL FEEDTHROUGHS

Attorney Docket No.: UOM 0281 PUSP

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Communication mailed February 14, 2006, please
amend the above-identified application as follows:

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this paper, including all enclosures referred to herein, is being deposited with the United States Postal Service as first-class mail, postage pre-paid, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450 on:

February 24, 2006
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Timothy J. Marsh
Name of Person Signing


Signature